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Docket No.: M-11749-4D US

January 11, 2002

Commissioner For Patents
Washington, D.C. 20231

Re: Applicant(s): Cohen, Adam L.
Assignee: University of Southern California
Title: Method For Electrochemical Fabrication
Serial No.: 09/493,496
Examiner: E. Smith-Hicks
Docket No.: M-11749-4D US Filed: January 28, 2000
Group Art Unit: 1741

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- (2) This Transmittal Letter (in duplicate);
- (3) Request for Additional Amendments (4 pages);
- (4) Request to Amend Drawings Under 37 CFR § 1.21(2 pages);
- (5) Information Disclosure Statement Under 37 CFR § 1.97 with Fee (1 page) (in duplicate);
- (6) PTO 1449 (1 page); and
- (7) Copies of 3 cited references.

- No additional fee is required.
 The fee has been calculated as shown below:

CLAIMS AS AMENDED (fees computed under 37 CFR §1.9(f))

Claims Remaining <u>After Amendment</u>	Minus	20	=	0	x \$ 9.00	\$	Highest No.	Additional Fee
							Previously Paid For	
Total Claims	12							0.00
Independent Claims	3	Minus	3	=	0	x \$42.00	\$	0.00
<input checked="" type="checkbox"/> Information Disclosure Statement Under 37 CFR § 1.97 with Fee						\$		180.00

Total additional fee for this Amendment:

- Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.
 Please charge our Deposit Account No. 19-2386 in the amount of \$ 0.00
 Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 19-2386.

Total: \$ 180.00

EXPRESS MAIL LABEL NO.:
EL 884 818 915 US

Respectfully submitted,

Norman R. Klivans
Norman R. Klivans
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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AS
1/25/2

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San Jose, California
January 11, 2002

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REQUEST FOR ADDITIONAL AMENDMENTS

Dear Sir/Madam:

This is a supplement to a Response to Office Action filed on November 20, 2001. Applicant respectfully requests entry of amendments as set forth below.

IN THE DRAWINGS

Please amend FIG. 20 as indicated in red on the enclosed marked up version of FIG. 20.

IN THE SPECIFICATION

In accordance with 37 C.F.R. §1.121(b)(3)(iii), Attachment A contains a marked up version of the amended paragraph indicating the newly introduced change.

Please replace the paragraph starting on page 15, line 23 with the following paragraph:

The micromold surface including the photoresist and the substrate can be passivated by allowing the micromold to be exposed to vapors of, e.g., (tridecafluoro-1,1,2,2-tetrahydrooctyl)-1-trichlorosilane, (commercially available from United Chemical

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